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To the Honorable Commissioner of Patents

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original documents or copy thereof.

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Kenji AMANO and Yoshitsugu TANAKA

2. Name and address of receiving party(ies):
Name: TOKYO ELECTRON LIMITED
Address: 3-6 Akasaka 5-chome, Minato-ku,
Tokyo 107-8481, Japan

Additional name(s) of conveying party(ies) attached? Yes No

3. Nature of Conveyance:
 Assignment Merger
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9/739701

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Execution Date: December 7, 2000

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4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is: December 7, 2000

A. Patent Application No.(s)

B. Patent No.(s)

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5. Name and address of party to whom correspondence concerning document should be mailed:

6. Total applications and patents involved: 1

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A S S I G N M E N T

In consideration of value received, I, having a mailing address at
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 invention described in an application for United States patent entitled:

VACUUM PROCESSING APPARATUS FOR SEMICONDUCTOR PROCESS

said application having been filed on _____
 and assigned Application No. _____ :

sell and assign to

TOKYO ELECTRON LIMITED

a corporation of Japan, having a business address at
 3-6 Akasaka 5-chome, Minato-ku, Tokyo 107-8481, Japan

its successors, assigns or nominees, hereinafter referred to as
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ASSIGNMENT

00S1081-1

Inventor: (Signature)

Date

Residence

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